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Response
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PATENT APPLICATION
-2 2003
TECHNOLOGY CENTER 2800

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
HIROSHI YOSHINO) Examiner: M. Nghiem
Application No.: 09/699,387) Group Art Unit: 2861
Filed: October 31, 2000)
For: INK JET APPARATUS AND)
WASTE LIQUID)
ABSORBING METHOD) December 18, 2002

Commissioner for Patents
Washington, D.C. 20231

RESPONSE TO OFFICE ACTION

Sir:

This is in response to the Office Action dated July 18, 2002, the term for responding to which having been extended to December 18, 2002 by the accompanying Petition For Extension Of Time.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231 on

December 18, 2002
(Date of Deposit)

Donna A. Duchene, Reg. No. 40,823

Name of Attorney for Applicant

D. D. V. 12/18/02
Signature Date of Signature